# AMENDMENTS TO THE CLAIMS

## 1-3. Canceled

4. (Currently Amended) An apparatus for formation of a three dimensional object by a sequential deposition of a wire feedstock comprising:

a sealed container capable of maintaining a vacuum environment;

a positioning subsystem contained within said container and capable of controlling the position of said object;

a wire feed subsystem contained within said container and capable of depositing said wire feedstock in solid form at a target location relative to said position of said object in a sequential manner, wherein said wire feed subsystem does not deposit said wire feedstock at said target location in the form of droplets;

an electron beam subsystem capable of directing energy within said container, directing energy relative to said position target location of said object, and melting said wire feedstock at said target location in a consistent with said sequential manner deposition of said wire feedstock, and sustaining a molten pool at said target location thereby forming said object in said sequential manner;

a vacuum subsystem capable of creating and sustaining said vacuum environment in said container;

an instrumentation subsystem electronically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, and vacuum subsystem; and

a power distribution subsystem electrically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, vacuum subsystem, and said instrumentation subsystem.

- (Original) The apparatus of Claim 4, further comprising a substrate attached to said
  positioning subsystem wherein said sequential deposition of said wire feedstock is initiated on
  said substrate.
- (Original) The apparatus of Claim 4, wherein said container is comprised of:

   a frame; and
   at least one wall attached to said frame.
- 7. (Original) The apparatus of Claim 6, wherein said frame and at least one wall is formed of a material selected from a group consisting of metal, metal alloy, ceramic, ceramic composite, metal matrix composite, and polymer matrix composite.
- 8. (Original) The apparatus of Claim 6, wherein said frame and at least one wall is formed of a material selected from the group consisting of titanium, aluminum, aluminum alloys, beryllium alloys and stainless steel.
- 9-10. Canceled
- 11. (Original) The apparatus of Claim 6, where said container is further comprised of:

at least one window attached to said at least one wall;

at least one door attached to said frame, to said wall, or both;

at least one electrical feed-through attached to said at least one wall; and

at least one plumbing feed-through attached to said at least one wall.

12. (Original) The apparatus of Claim 11, wherein said window is formed of a transparent

material.

13. (Original) The apparatus of Claim 11, wherein said at least one door is formed of a

material selected from a group consisting of metal, metal alloy, ceramic, and ceramic composite.

14. (Original) The apparatus of Claim 4, wherein said container has a rectilinear, ellipsoidal,

or arbitrary cross-sectional shape.

15. (Original) The apparatus of Claim 4, wherein said electron beam subsystem is comprised

of:

an electron beam gun capable of directing said energy;

an electron beam control element capable of controlling the delivery of said energy from

said electron beam gun and electronically connected to said instrumentation subsystem and said

electron beam gun; and

an electron beam power subsystem electrically connected to said electron beam gun and

said electron beam control element and wherein said electron beam power subsystem is capable

of supplying power to said electron beam gun and said electron beam control element.

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16-18. Canceled

19. (Previously Presented) The apparatus of Claim 15, wherein said electron beam subsystem

is further comprised of:

at least one auxiliary vacuum pump connected to said electron beam gun, electrically

connected to said power distribution subsystem, and capable of creating and sustaining a vacuum

level within said electron beam gun;

at least one service panel attached to said electron beam gun and electrically connected to

said power distribution subsystem; and

at least one user interface screen electronically connected to said electron beam control

element and electrically connected to said power distribution subsystem.

(Original) The apparatus of Claim 15, wherein said electron beam subsystem is further

comprised of an electron beam positioning subsystem capable of positioning said electron beam

gun relative to said position of said object wherein said electron beam positioning subsystem is

electronically connected to said electron beam control element and electrically connected to said

power distribution subsystem.

21. (Original) The apparatus of Claim 15, wherein said electron beam subsystem is further

comprised of an electron beam positioning subsystem capable of positioning said electron beam

gun relative to said position of said object wherein said electron beam positioning subsystem is

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electronically connected to said instrumentation subsystem and electrically connected to said power distribution subsystem.

- Canceled
- (Previously Presented) The apparatus of Claim 15, wherein said electron beam power subsystem is rated at a voltage range from about 100V to about 240V.
- (Previously Presented) The apparatus of Claim 23, wherein said electron beam power subsystem is rated at about 110V.
- (Previously Presented) The apparatus of Claim 15, wherein said electron beam gun is partially contained inside said container.
- (Previously Presented) The apparatus of Claim 15, wherein said electron beam power subsystem is rated to provide an accelerating voltage up to about 60kV.
- (Previously Presented) The apparatus of Claim 26, wherein said electron beam power subsystem is rated to provide an accelerating voltage up to about 15kV.
- 28. (Previously Presented) The apparatus of Claim 15, wherein said electron beam power subsystem is rated to provide a beam power from about 3kW to about 10kW.

- (Previously Presented) The apparatus of Claim 28, wherein said electron beam power subsystem is rated to provide a beam power from about 3kW to about 5kW.
- (Original) The apparatus of Claim 4, wherein said positioning subsystem is comprised of:

a moveable platform contained within said container;

at least one positioning subsystem motor capable of moving said moveable platform and electrically connected to said power distribution subsystem; and

a positioning subsystem control element capable of controlling said position of said object, wherein said positioning subsystem control element is electronically connected to said instrumentation subsystem, said moveable platform, and said at least one positioning subsystem motor, and wherein said positioning subsystem control element is electrically connected to said power distribution subsystem.

## Canceled

- (Original) The apparatus of Claim 30, wherein said moveable platform is a four axes moveable platform.
- 33. (Previously Presented) The apparatus of Claim 32, wherein said positioning subsystem control element is rated to control said four axes moveable platform within about +/- 0.001 for each linear axis of X, Y, and Z and about 0.01 degrees for the a-axis of rotation in the X-Y plane.

- 34. (Previously Presented) The apparatus of Claim 32, wherein said positioning subsystem control element is rated to control said four axes moveable platform within a translational speed up to about 250 inches per minute for each linear axis of X, Y, and Z and a rotational speed up to about 20 rotations per minute for the a-axis of rotation in the X-Y plane.
- 35. (Previously Presented) The apparatus of Claim 34, wherein said positioning subsystem control element is rated to control said four axes moveable platform within a translational speed up to about 50 inches per minute for each linear axis of X, Y, and Z and a rotational speed up to about 10 rotations per minute for the a-axis of rotation in the X-Y plane.
- (Original) The apparatus of Claim 30, wherein said moveable platform is a five axes moveable platform.
- (Original) The apparatus of Claim 4, wherein said wire feed subsystem is comprised of: said wire feedstock;

a wire feed housing contained within said container and capable of accommodating said wire feedstock:

at least one wire feed motor attached to said wire feed housing and electrically connected to said power distribution subsystem:

a wire feeding mechanism attached to said wire feed housing, mechanically connected to said wire feed motor, and wherein said wire feedstock is threaded through said wire feeding mechanism;

at least one wire feed nozzle attached to said wire feed housing and wherein said wire feedstock is fed through said wire feed nozzle; and

a wire feed control element electronically connected to said instrumentation subsystem, said wire feed motor, said wire feeding mechanism, and said at least one wire feed nozzle and electrically connected to said power distribution subsystem.

## 38-42. Canceled

 (Previously Presented) The apparatus of Claim 4, wherein said vacuum subsystem is comprised of:

a plumbing subsystem connected to said container;

at least one pump connected to said plumbing subsystem and capable of creating and sustaining said vacuum environment in said container; and

a vacuum control element electrically connected to said power distribution subsystem, electronically connected to said instrumentation subsystem, and capable of controlling said at least one pump and said plumbing subsystem.

44. (Previously Presented) The apparatus of Claim 43, wherein said plumbing subsystem, said at least one pump, and said vacuum control element are capable of creating and sustaining a pressure from about  $10^4$  torr to about  $10^6$  torr in said container.

## 45-46. Canceled

- 47. (Previously presented) The apparatus of Claim 43, wherein said at least one pump is selected from a group consisting of a turbomolecular pump, a scroll pump, an ion pump, a roughing pump, a cryopump, and a diffusion pump.
- 48. (Previously presented) The apparatus of Claim 43, wherein said vacuum control element is comprised of at least one vacuum subsystem sensor electronically connected to said instrumentation subsystem, said at least one pump, and said plumbing subsystem.
- (Original) The apparatus of Claim 4, wherein said instrumentation subsystem is comprised of:
- a means for commanding and controlling data electrically connected to said power distribution subsystem and electronically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, and vacuum subsystem;
- a means for measuring processing conditions electronically connected to said means for commanding and controlling data; and
- a means for recording data electronically connected to said means for commanding and controlling data.
- 50. (Previously Presented) The apparatus of Claim 4, wherein said instrumentation subsystem is further comprised of:
- a visual monitoring means for monitoring the fabrication process electronically connected to the means for commanding and controlling data; and

a means for monitoring a predetermined set of parameters related to the fabrication process electronically connected to the means for commanding and controlling data.

## 51-52. Canceled

53. (Original) The apparatus of Claim 4, wherein said power distribution subsystem is comprised of:

a means for providing an electrical connection electrically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, vacuum subsystem, and said instrumentation subsystem;

a means for conditioning power electrically connected to said means for providing an electrical connection:

a means for apportioning power electrically connected to said means for providing an electrical connection:

a means for distributing power electrically connected to said means for providing an electrical connection; and

a means for protecting system components from electrical hazards electrically connected to said means for providing an electrical connection.

## Canceled

- 55. (Original) The apparatus of Claim 53, wherein said power distribution subsystem further comprises a means for managing power electrically connected to said means for electrical connection.
- 56. (Currently Amended) An apparatus for formation of a three dimensional object by a sequential deposition of a wire feedstock comprising:
  - a sealed container capable of maintaining a vacuum environment;
- a positioning subsystem contained within said container and capable of controlling the position of said object;

an electron beam subsystem capable of directing energy within said container and directing energy relative to said position target location of said object;

a wire feed subsystem contained within said electron beam subsystem and capable of depositing said wire feedstock in solid form to a target location relative to said position of said object in a sequential manner, wherein said wire feed subsystem does not deposit said wire feedstock to said target location in the form of droplets;

a vacuum subsystem connected to said container and capable of creating and sustaining said vacuum environment in said container;

an instrumentation subsystem electronically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, and vacuum subsystem; and

a power distribution subsystem electrically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, vacuum subsystem, and said instrumentation subsystem,

wherein the said electron beam subsystem is capable of melting said wire feedstock at said target location in a consistent with said sequential manner deposition of said wire feedstock, and sustaining a molten pool at said target location thereby forming said object in said sequential manner.

57. (Currently Amended) An apparatus for formation of a freeform three dimensional object comprising:

a containment means for enclosing a workspace;

a delivery means contained within said containment means and for depositing a feedstock material in a solid form, in a predetermined pattern, and a predetermined rate onto a target, wherein said delivery means does not deposit said feedstock material onto said target in the form of droplets:

a positioning means contained within said containment means and for positioning said target to a predetermined location:

an electron beam subsystem capable of directing energy within said container and directing energy relative to said target and melting said feedstock at said target location in a sequential manner and sustaining a molten pool at said target location thereby forming said object consistent with said predetermined pattern and at said predetermined rate;

an atmospheric pressure control means connected to said containment means and for creating and maintaining a vacuum environment inside said containment means; a command, control, and communications means electronically connected to said containment means, electronically connected to said delivery means, electronically connected to said heating means, electronically connected to said atmospheric control means, and for communications for said delivery means, said heating means, said positioning means, and said atmospheric pressure control means; and

a power distribution means electrically connected to said delivery mean, said heating means, said positioning means, said atmospheric control means, and said command, control, and communications means and for distributing power to said delivery means, said positioning means, said heating means, said atmospheric pressure control means, and said command, control, and communications means.

58. (Currently Amended) An apparatus for formation of a three dimensional object in interplanetary space by a sequential deposition of a wire feedstock comprising:

a frame;

a positioning subsystem attached to said frame and capable of controlling the position of said object;

a wire feed subsystem attached to said frame and capable of depositing said wire feedstock in a solid form relative to a target location relative to said position of said object in a sequential manner, wherein said wire feed subsystem does not deposit said wire feedstock to said target location in the form of droplets;

an electron beam subsystem capable of directing energy relative to said position of said object, and melting said wire feedstock at said target location in a consistent with said sequential manner deposition of said wire feedstock, and sustaining a molten pool at said target location thereby forming said object in said sequential manner;

an instrumentation subsystem electronically connected to said electron beam subsystem, positioning subsystem, and wire feed subsystem; and

a power distribution subsystem electrically connected to said electron beam subsystem, positioning subsystem, wire feed subsystem, and said instrumentation subsystem.

59. (Withdrawn) A method for fabricating a three dimensional object from a wire material in a solid freeform fabrication apparatus comprising a sealed container, an electron beam gun, a positioning element, and a wire feed subsystem said method comprising the steps of:

affixing a substrate material to said positioning element;

de-pressurizing said sealed container to a predetermined pressure;

positioning said substrate by moving said positioning subsystem to a predetermined location relative to said substrate and said wire feed subsystem;

heating said substrate with said electron beam gun to create and sustain a molten pool;

depositing said wire material on said substrate and into said molten pool in layers from
said wire feed subsystem; and

building successive layers on said substrate by repeating said positioning, heating, and depositing steps.